

L Number	Hits	Search Text	DB	Time stamp
33	22799	((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 12:43
40	0	US-20020001051-A1.DID. near20 (seal\$3 cover\$3 cap\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:37
111	1374	(sacrificial disposable) near12 (polyimide photoresist)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 12:55
118	467	((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) and ((sacrificial disposable) near12 (polyimide photoresist))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 12:55
125	1730	((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 cap\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:05
132	72	((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:05
139	22	((lid cap\$4 cover\$3\$3) near12 (metal aluminum)) and (((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:34
146	974	((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 capped cap capping)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:05
153	35	((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 capped cap capping) and ((sacrificial disposable) near12 (polyimide photoresist))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:05
160	22	((lid cap\$4 cover\$3) near12 (metal aluminum)) and (((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:40
167	0	((encapsul?nt encapsulat\$3) near12 (metal aluminum)) and (((MEMS or microelectromechanical or micromechanical or (micro adj (mechanical or electromechanical or (electro adj mechanical)))) (microfabricat\$3 or (micro adj fabricat\$3))) (micromachin\$3 or (micro adj machin\$3))) near20 (seal\$3 cover\$3 cap\$4) and ((sacrificial disposable) near12 (polyimide photoresist)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:36

174	275	(sealed capped covered) near3 (MEMS microstructure microdevice micromechanical microelectromechanical microoptoelectromechanical microopto microoptic micromirror microoptomechanical micromachined microfabricated)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:39
181	66	((lid cap\$4 cover\$3) near12 (metal aluminum)) and ((sealed capped covered) near3 (MEMS microstructure microdevice micromechanical microelectromechanical microoptoelectromechanical microopto microoptic micromirror microoptomechanical micromachined microfabricated))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/12/14 13:40